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APPLICANTS

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** CONTINUING DATA *****

This application is a 371 of PCT/JP03/08317 07/01/2003

** FOREIGN APPLICATIONS *****

JAPAN 2002-197365 07/05/2002
 JAPAN 2002-357945 12/10/2002

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|---------------------------------|---|----------|---------------------------|-------------------------|
| Foreign Priority claimed | <input type="checkbox"/> yes <input type="checkbox"/> no | | | |
| 35 USC 119 (a-d) conditions met | <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance | | | |
| Verified and Acknowledged | Examiner's Signature | Initials | STATE OR COUNTRY JAPAN | SHEETS DRAWING 19 |
| | | | TOTAL CLAIMS 34 | INDEPENDENT CLAIMS 5 |

ADDRESS

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TITLE

Method of cleaning substrate-processing device and substrate-processing device

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| FILING FEE RECEIVED 2100 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit |
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